

<b>Search Notes</b>	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/531,627	VAN DAMME
Examiner	Art Unit	
John S. Chu	1752	

<b>INTERFERENCE SEARCHED</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>